



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: INOUE et al.

Group Art Unit: 2823

Serial No.: 09/228,148

Examiner: MALDONADO, Julio

Filed: July 11, 1999

Confirmation No.: 7239

For: SEMICONDUCTOR DEVICE INCLUDING AN INSULATION FILM ON
A CONDUCTIVE LAYER AND MANUFACTURING METHOD
THEREOF

Attorney Docket No.: 970150A

Customer Number: 38834

INFORMATION DISCLOSURE STATEMENT PURSUANT TO 37 C.F.R. §1.97(b)

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

March 11, 2004

Sir:

The attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached Form PTO-1449. One copy of each of these documents is attached.

It is noted that some of the listed documents had already been submitted, but were not expressly acknowledged by the Examiner.

No fee or certification is required in connection with this Information Disclosure Statement, it is being submitted prior to the issuance of a first official action on the merits in the above-identified patent application.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that

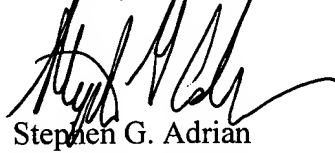
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the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

The Commission is authorized to charge Deposit Account No. 50-2866 for any fee which is deemed by the Patent and Trademark Office to be required to effect consideration of this statement.

Respectfully Submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

A handwritten signature in black ink, appearing to read 'Stephen G. Adrian', is written over the printed name.

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Enclosures: PTO-1449; 9 Refs

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INFORMATION DISCLOSURE CITATION PTO-1449	Atty. Docket No. 970150A	Serial No. 09/228,148
	Applicant(s): INOUE, ET AL.	
	Filing Date: July 11, 1999	Group Art Unit: 2823

U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA	4,920,071	Thomas, M.	04/1990			
_____	AB	5,541,445	Quellet, L.	07/1996			
_____	AC						
_____	AD						

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation (Yes or No)
_____	AE	9-69562	03/1997	Japan	Abstract
_____	AF	9-312339	12/1997	Japan	Abstract
_____	AG	9-246375	09/1997	Japan	Abstract
_____	AH	EP 0 602 607 A1	06/1994	Europe	
_____	AI	0179563	11/1998	Korea	Abstract
_____	AJ				

OTHER DOCUMENTS

_____	AK	Yoshio Homma, et al., "Using Selective CMP with Low Permittivity Organic SOG to Achieve Low Capacitance Multilevel Interconnection" VMIC Catalog No. 95ISMIC-104, 1995, PP. 457-463.
_____	AL	
Exami ner		Date Considered

